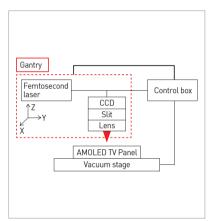
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# AMOLED TV Non-thermal Repair Technology

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Application

T. +82 - 42 - 868 - 7077 E. shcho@kimm.re.kr Ultrashort pulse laser—based AMOLED TV non—thermal repair technology and repair device



## Client / Market

 Companies interested in non-thermal repair machining technology of large size AMOLED panel

# **Necessity of this Technology**

- Non—thermal repair process is necessary, and a system for large size processing needs to be established.
- Repair process using nanosecond laser inevitably causes thermal damage to the object.
- In case of processing an organic matter that is very sensitive to the processing temperature, unnecessary damages are caused from heat around the processing unit.
- When defect or error occurs during large size AMOLED panel manufacturing, the entire quantity is discarded. From the production yield perspective, this is a serious downside, therefore a repair technology is needed.

## **Technical Differentiation**

- Ultrashort pulse laser has relatively short pulse width compared to nanosecond laser and can be used for non-thermal processing to minimize damage from heat on the object.
- With the ultrashort laser machining system using a gantry, a large size AMOLED panel can be repaired.
- The beam size can be adjusted with the motorized slit to adjust the beam shape in the light path of the ultrashort pulse laser—based machining system, and with the square—shaped beam, machining of area requiring repair can be executed with the minimum line width of 500 nm.
- Using the gantry established for this system, the defective area of the large size AMOLED panel is detected and is quickly repaired using the ultrashort pulse laser.

## **Excellence of Technology**

- The process irradiates the femtosecond laser beam to the target layer and processes the desired area. It is utilized for partial repair of a specific defective area.
- For this, the beam shape and the machining size is adjusted through the slit.

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DESIRED PARTNERSHIP

## Technology Transfer

#### Licensing

#### nsina

### Joint Research

Other



## TECHNOLOGY READINESS LEVEL [TRL]

Research, | Project concept or | Technology | Prototype | Trial product production/ | Pilot field | Development and optimization | Commercial product | Mass production and evaluation in similar environment | demonstration | of commercial model | demonstration | initial market launch

- It is the blueprint that roughly shows the active organic self—illuminator TV's femtosecond laser repair system. For large area repair, the gantry system is used to adjust the laser beam location, not the target for repair, for machining.
- The repair target is fixed with the vacuum chuck of the stage to minimize the elevation difference error.
- The head researcher for this technology has over 10 years of research experience in ultrashort femtosecond laser—applied superprecision micro machining field.



## **Current Intellectual Property Right Status**

## PATENT

- Non—thermal Repair Method and Device for Full HD High Resolution Mobile Active Organic Self—illuminator (KR1477005)
- Non-thermal Repair Method and Device for Active Organic Self-illuminator Using Selective Pulse Width Tunable Laser (KR1450767)
- Thermal and Non-thermal Converged Repair Device for Active Organic Self-illuminator (KR1387996)
- Non—thermal Repair Method and Device for Transparent Active Organic Self illuminator Using Ultrashort Pulse Laser (KR2012–0042367)
- Non-thermal Repair Method and Device for Large Size Active Organic Selfilluminator Using Ultrashort Pulse Laser (KR2012-0056576)
- Non-thermal Repair Method and Device for Active Organic Self-illuminator Using Ultrashort Pulse Laser (KR2012-0016303)
- Non—thermal Repair Method and Device for Flexible Active Organic Self—illuminator Using Ultrashort Pulse Laser (KR2012—0016139)

